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PATENT

CofC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:

KAZUTO HOSOI ET AL.

Appln. No.: 10/691,514

Filed: October 24, 2003

For: DEPOSITED FILM FORMING APPARATUS AND DEPOSITED FILM FORMING METHOD

U.S. Patent No.: 6,946,167 B2

Issued: September 20, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Certificate
JAN 13 2006
of Correction

LETTER CALLING ATTENTION TO ERRORS IN PATENT

Sir:

The following minor errors have been noted in the above-mentioned patent:

COLUMN 2:

Line "valve 1241" should read --valves 1241--; and
Line "controller" should read --controllers--

COLUMN 6:

Line 24, "substrates 12" should read --substrates 1112--.

COLUMN 9:

Line 25, "e.g." should read --e.g.,--; and
Line 31, "e.g." should read --e.g.,--.

COLUMN 11:

Line 42, "CIF, CIF₃," should read --ClF, ClF₃,--.

COLUMN 16:

Line 64, "conditionshown" should read --conditions shown--.

COLUMN 17:

Line 20, "member" should read --members--.

COLUMN 19:

Line 40, "th" should read --the--.

These errors appear to be relatively insignificant and, therefore, we do not believe it is necessary to request a Certificate of Correction. However, it is requested that this paper be placed in the filewrapper of the above-identified patent.

Patentees' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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